

<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application <b>10/500,425</b>		OFGS File No. <b>P/2107-253</b>			
		Applicant <b>Achim WEBER</b>					
		Filing Date <b>September 7, 2004</b>		Group Art Unit <b>1645</b>			
<b>U.S. PATENT DOCUMENTS</b> (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-						
	US-						
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<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)							
/MY/		Y. Xia et al., "Soft Lithography", <i>Angew. Chem. Int. Ed.</i> , 37:550-575 (1998).					
Examiner		/Melanie Yu/ (11/06/2007) Date Considered					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							